

राष्ट्रीय प्रौद्योगिकी संस्थान सिलचर National Institute of Technology Silchar

(राष्ट्रीय महत्व का संस्थान)

(An Institute of National Importance)

www.nits.ac.in, Phone: 03842-242914, Fax: 03842-224797, Assam-788010 (INDIA)

Advertisement No.: NITS/Dean(RC)/ME/548/02/2020

Date: 17.12.2020

Applications are invited from Indian citizens for a temporary of post of <u>Junior Research Fellow (JRF)</u> for the <u>CSIR EMR-II</u> sponsored project in the Department of Mechanical Engineering NIT Silchar.

Title of the project	Design and Development of a High Speed Three Dimensional Printer			
	with a Large Range of Micro Motion using a Scanning Projection			
	Stereo-lithography Technique			
Sponsored Agency	CSIR EMR-II			
Project sanction number 22(0831)/19/EMR-II dated 02.12.2019				
No. of posts 01				
Duration	03 years			
Principal Investigator (P.I)	Dr. Yogesh Singh			

General Information and Terms & Conditions

1.	Age Limit	28
2.	Essential Qualification	M.E., M. Tech or equivalent degree in Mechanical Engineering /
		Technology streams (Manufacturing/Design/CAD-
		CAM/Mechatronics) (GATE/NET qualified)
3.	Desirable Qualification	Masters Degree in Design and Manufacturing Engineering/CAD-CAM
		and Automation/ Manufacturing Engineering with research experience
		in the field of robotics, compliant mechanism and mechatronics with
		first class in B.E/B. Tech. & M.E. / M. Tech.
4.	Salary	Rs. 31,000/- per month
	1161	
5.	Relaxation on qualification and	SC/ST/OBC/WOMEN/PWD/EWS candidates will get
	age	relaxation as per Govt of India Rules.
6.	<u> </u>	02.01.2021
	of filled up application form	
7.	Reporting	Applicants are requested to submit their filled-up applications along
		with C.V. to the P.I. accompanying photocopies of all documents.
		Applicants are also requested to send the soft copy of the duly filled
		application along with C.V. & all necessary documents to the P.I
		through email (<u>yogesh@mech.nits.ac.in</u>) on or before 02.01.2021.
8.		11.01.2021, 11.00 AM, Department of Mechanical Engineering, NIT
		Silchar
9.	No objection certificate	Employed candidates are to submit no objection certificate from
		his/her employer at the time of interview.
10.	Institute right	The Institute has the discretion to restrict the number of candidates to
		be called for the interview on the basis of screening. No candidate
		may be recruited if suitable candidates are not found.
11.	Signing of the agreement	Selected candidates shall have to sign an agreement at the time of
		joining.

Sd/- Associate Dean (R&C) NIT Silchar.

National Institute of Technology Silchar

FORMAT of APPLICATION

for Junior Research Fellow

Paste recent passport size colored photograph

1.	Advertisement no dated:				
2.	Title of the Project-				
3.	Department:				
4.	Name of the applicant (in block letters):				
5.	Father's/Husband's Name:				
6.	Date of Birth (DD-MM-YYYY):				
7.	Age as on 02 nd Jan, 2021:				
8.	Postal Address:				
	E-mail: Phone no.:				
9.	Permanent Address:				
10	. Nationality:				
11	. Marital Status:				
12	. Whether belongs to SC/ST/ OBC/PwD/EWS: (If yes, attach certificate):				
13	Educational Qualification: (Starting from Class X)				

Exam. passed	Board/ University	Divi sion	% age of marks / CPI	Year of passing	Subjects

14. NET/GATE Examinations Passed	d:
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	I. NE	Τ	I	I. GATE	Ξ
Subject	Qualifying date	Valid upto	Subject	Score	Valid upto

15. Details of employments:

S1. No.	Name of the Organization	Name of the post	Period	Scale of pay and present pay	Nature of duty

16. Any other relevant information that you may like to furnish:

Declaration

]	I declare t	hat the abov	e information	are true and	d correct to	the best o	f my
knowle	edge and b	oelief.					

Date:	
Place	Signature of the applicant